

Notice of References Cited	Application/Control No. 10/812,075		Applicant(s)/Patent Under Reexamination SEKIGUCHI ET AL.	
	Examiner Cecilia M. Jaisle		Art Unit 1624	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,691,321	11-1997	Schaper et al.	514/63
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	WO 2001096295	12-2001	WIPO	Villhauer, et al.	
	O	WO 1996/06086	02-1996	WIPO	Obata, et al.	
	P	WO 1999/31072	06-1999	WIPO	Lee, et al.	
	Q	EP 1464335	10-2004	EPO	Sekiguchi, et al.	
	R	WO 2003035638	05-2003	WIPO	Kubo, et al.	
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U				
	V				
	W				
	X				

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.